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**** CONTINUING DATA *******

**** FOREIGN APPLICATIONS *******

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Verified and Acknowledged <i>[Signature]</i> Examiner's Signature	Initials DVN			

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TITLE

Polishing pad, method of manufacturing glass substrate for use in data recording medium using the pad, and glass substrate for use in data recording medium obtained by using the method

FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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